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2823

Docket No.: 43890-485

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of

Hiroshi HAJI, et al.

Serial No.: 09/781,563

Filed: February 13, 2001

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

: Customer Number: 20277  
: Confirmation Number: 2296  
: Group Art Unit: 2823  
: Examiner: George R. Fourson III

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**REQUEST FOR RECONSIDERATION**

Mail Stop Non-Fee Response  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 8, 2003, having a three-month shortened statutory period for response set to expire on October 8, 2003, reconsideration of the above-identified application is respectfully requested in view of the following remarks.